ITC

ION TECHNOLOGY CENTRE

Order form (version 3) for

Ion Implantation

Ordered by …….. Telephone ……

Account no.* ……

Implantation date* ……..

Ion …… Tilt angle ……..

Target heating …… Batch no.* ……

General comments* ……
……

Wafer no.	Target Position*	Energy (keV)	Dose (cm^{-2})	Comments*

* Optional information, or filled in by operator

Operator* .....